

8-1-3

(2-92)

Sheet 1 of 3

Form PTO-1449 <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>		Docket Number (Optional) 3375.9US (95-0999.08/US)	Application Number Not yet assigned
		Applicant Donald L. Yates	
		Filing Date August 1, 2003	Group Art Unit Unknown

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JHS</i>	4,132,567	01/1979	Blackwood			
	4,197,000	04/1980	Blackwood			
	4,286,541	09/1981	Blackwood			
	4,635,666	01/1987	Daley et al.			
	4,682,615	07/1987	Burkman et al.			
	4,911,761	03/1990	McConnell et al.			
	4,984,597	01/1991	McConnell et al.			
	4,997,490	03/1991	Vetter et al.			
	5,069,235	12/1991	Vetter et al.			
	5,095,927	03/1992	Thompson et al.			
<i>JHS</i>	5,115,576	05/1992	Roberson, Jr. et al.			

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>JHS</i>	0,385,536	05/1990	EP				
	61-154130	07/1986	Japan				
	4-99025	03/1992	Japan				
	4-152525	05/1992	Japan				
<i>JHS</i>	4-253332	09/1992	Japan				

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

<i>JHS</i>	<i>JHS</i>	Handbook of Semiconductor Wafer Cleaning Technology, editor W. Kern, Noyes Publications, pp. 131-51 and 405-15.
		Koppenbrink et al., Particle Reduction on Silicon Wafers as a Result of Isopropyl Alcohol Vapor Displacement Drying after Wet Processing, Particles on Surfaces 2, editor K. Mittal, Plenum Press. pp. 235-43.
		Marra et al., Physical Principles of Marangoni Drying, Langmuir, Vol. 7, No. 11, pp. 2748-55.

EXAMINER	<i>JHS</i>	DATE CONSIDERED	<i>1/11/05</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance. Not considered. Include copy of this form with next communication to the applicant.

Form PTO-1449  INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (Use several sheets if necessary)		Docket Number (Optional) 3375.9US (95-0999.08/US)	Application Number Not yet assigned
		Applicant Donald L. Yates	
		Filing Date August 1, 2003	Group Art Unit Unknown

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
THS	5,186,192	02/1993	Netsu et al.			
	5,328,867	07/1994	Chien et al.			
	5,371,950	12/1994	Schumacher			
	5,520,744	05/1996	Fujikawa et al.			
	5,556,479	09/1996	Bran			
	5,653,045	08/1997	Farrell			
	5,660,642	08/1997	Britten			
	5,681,397	10/1997	Li			
	5,714,203	02/1998	Schellenberger et al.			
	5,727,578	03/1998	Matthews			
	5,752,532	05/1998	Schwenkler			
THS	5,845,660	12/1998	Shindo et al.			

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
THS	4-354128	12/1992	Japan			X	
THS	5-47734	02/1993	Japan			X	

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

THS	Leenaars et al., <i>Marangoni Drying: A New Extremely Clean Drying Process</i> , Langmuir, Vol. 6, No. 11, pp. 1701-03.
THS	Wong et al., "Post-Acid Rinse Enhancement Through Megasonic Quickdump Rinsing", February 1997, pps. 1-7.

EXAMINER	<i>THS</i>	DATE CONSIDERED	1/11/05
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Form PTO-1449 <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>		Docket Number (Optional) <b>3375.9US (95-0999.08/US)</b>	Application Number <b>Not yet assigned</b>
		Applicant <b>Donald L. Yates</b>	
		Filing Date <b>August 1, 2003</b>	Group Art Unit <b>Unknown</b>

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JHS</i>	5,934,299	08/1999	Akatsu et al.			
	5,951,779	09/1999	Koyanagi et al.			
	5,958,146	09/1999	Mohindra et al.			
	6,001,191	12/1999	Kamikawa et al.			
	6,125,863	10/2000	Bexten			
	6,138,690	10/2000	Nakatani			
	6,350,322	02/2002	Yates			
<i>JHS</i>	6,601,595	08/2003	Yates			

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER	<i>JHS</i>	DATE CONSIDERED
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